



Corres. and Mail  
**BOX AF**

**Amendment Under 37 C.F.R. § 1.116  
Expedited Procedure – Art Unit 2823**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Liming Tsau

Appl. No.: 10/750,834

Filed: January 5, 2004

**For: High Density Metal Capacitor  
Using Via Etch Stopping Layer as  
Field Dielectric in Dual-  
Damascene Interconnect Process**

Confirmation No.: 2507

Art Unit: 2823

Examiner: Khiem D. Nguyen

Atty. Docket: 1875.0230001

**Reply Under 37 C.F.R. § 1.116**

**Box AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the final Office Action dated **July 5, 2005**, Applicant submits the following Remarks.

It is not believed that extensions of time or fees for net addition of claims are required beyond those that may otherwise be provided for in documents accompanying this paper. However, if additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to our Deposit Account No. 19-0036.

OKAY TO ENTER

K.N.

10/04/05